

Beryllium and Lithium Compound Refractive X-ray Lenses at APS

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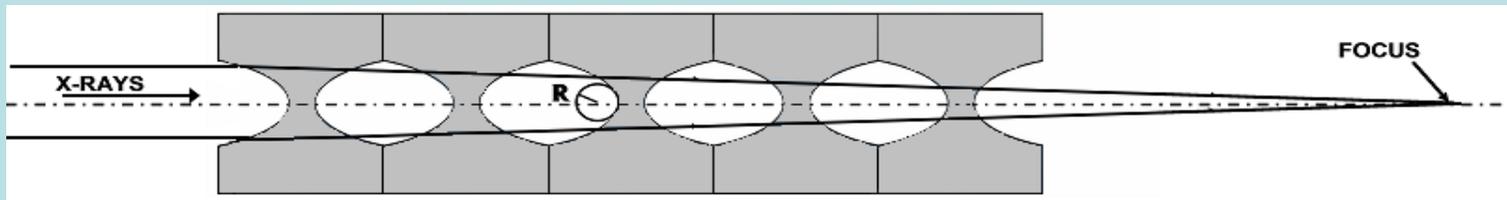


Background

- Mirrors, crystals, zone-plates, lenses, capillaries, and wave guides are used to focus x-rays.
- Selection is based on the applicability, availability, throughput, ease of use, cost, etc.
- Compound refractive lenses (CRLs) are a relatively recent addition.
- CRLs are arrays of (contiguous or modular) concave lenslets used in tandem to focus x-rays.
- CRLs advantages: simple design, ease of implementation and alignment, low cost, insensitivity to surface figure and finish.

Compound Refractive Lens

An CRL with five stacked lenslets



Focal Length

$$f = \frac{R}{2N\delta}$$

Radius

Index of Ref. decrement

Number of lenslets

Focal Size

$$S'_{h,v} = \frac{S_{h,v}}{D}$$

Source Size

Demagnification Factor

Lens Selection

Factors to consider regarding CRLs:

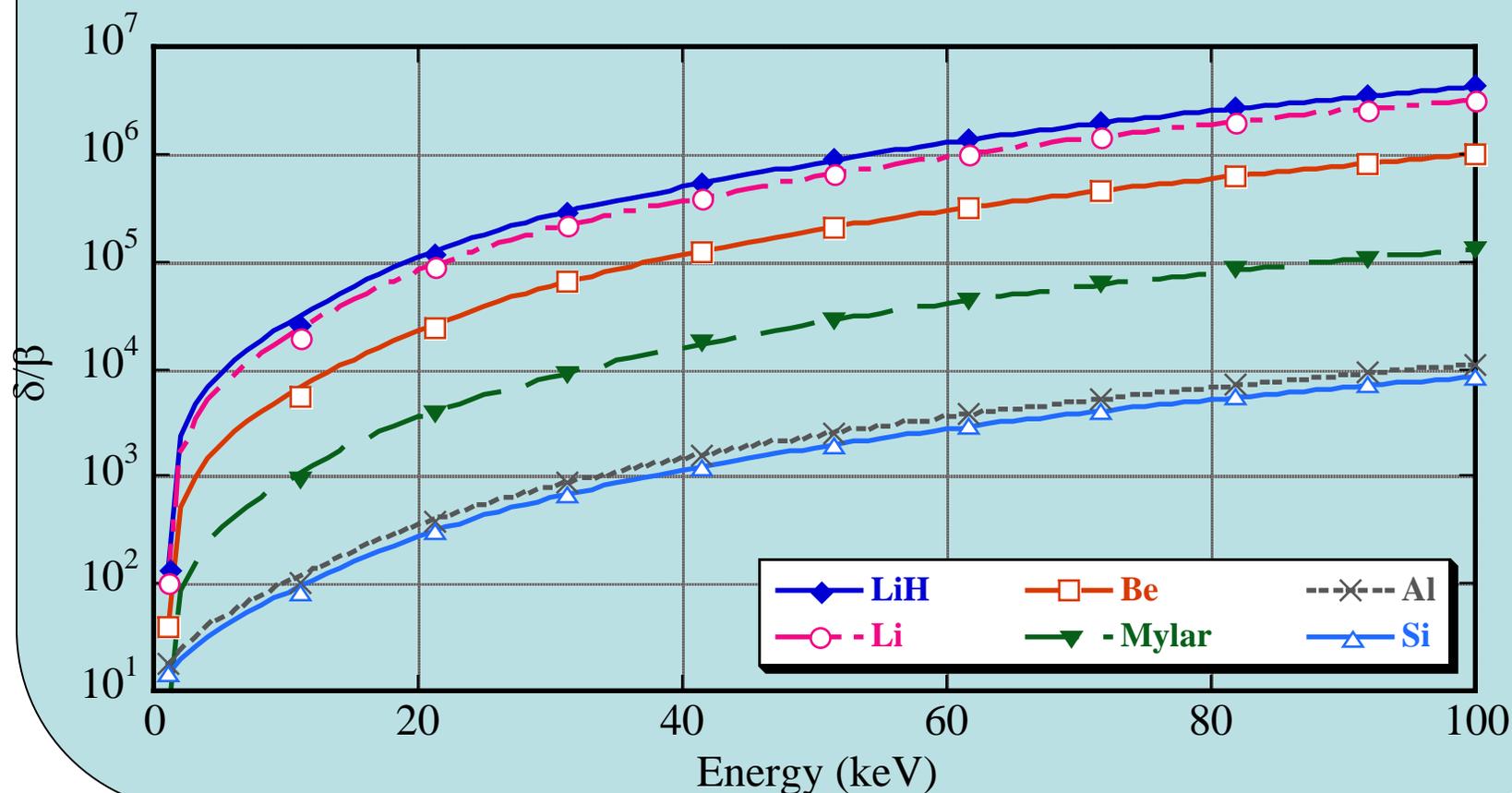
- Photon energy
- Beam size
- Desired focal length
- Desired focus size (and 1-D / 2-D focusing)

These in turn help determine...

- Lens material (absorption is a serious issue)
- Lens design
- Fabrication technique
- Alignment and assembly

Lens materials used include Li, Be, Al, Si, PMMA, Mylar

Material Figure of Merit:Focusing/Absorption



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Lithium

- High δ/β over a broad energy range
- Soft and malleable material
- But
- Reacts with oxygen, nitrogen, hydrogen, and strongly with water and moisture
- Tends to adhere to surfaces or forming dies
- Poor surface characteristics

- LiH is the best choice, we would like to explore it.

Beryllium

- High δ/β over a broad energy range
- Readily machinable metal
- High stiffness, strength, and ductility
- Available in a variety of grades, including fine-grain
- It can be polished
- Routine handling is safe
- But
- Hazardous material
- Fabrication requires safety measures (a few vendors)

Li Lens Fabrication Process



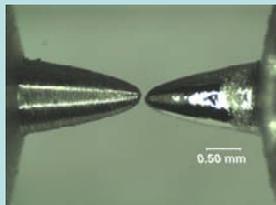
1. Lithium foil



2. Lithium disk



3. Cartridge unit

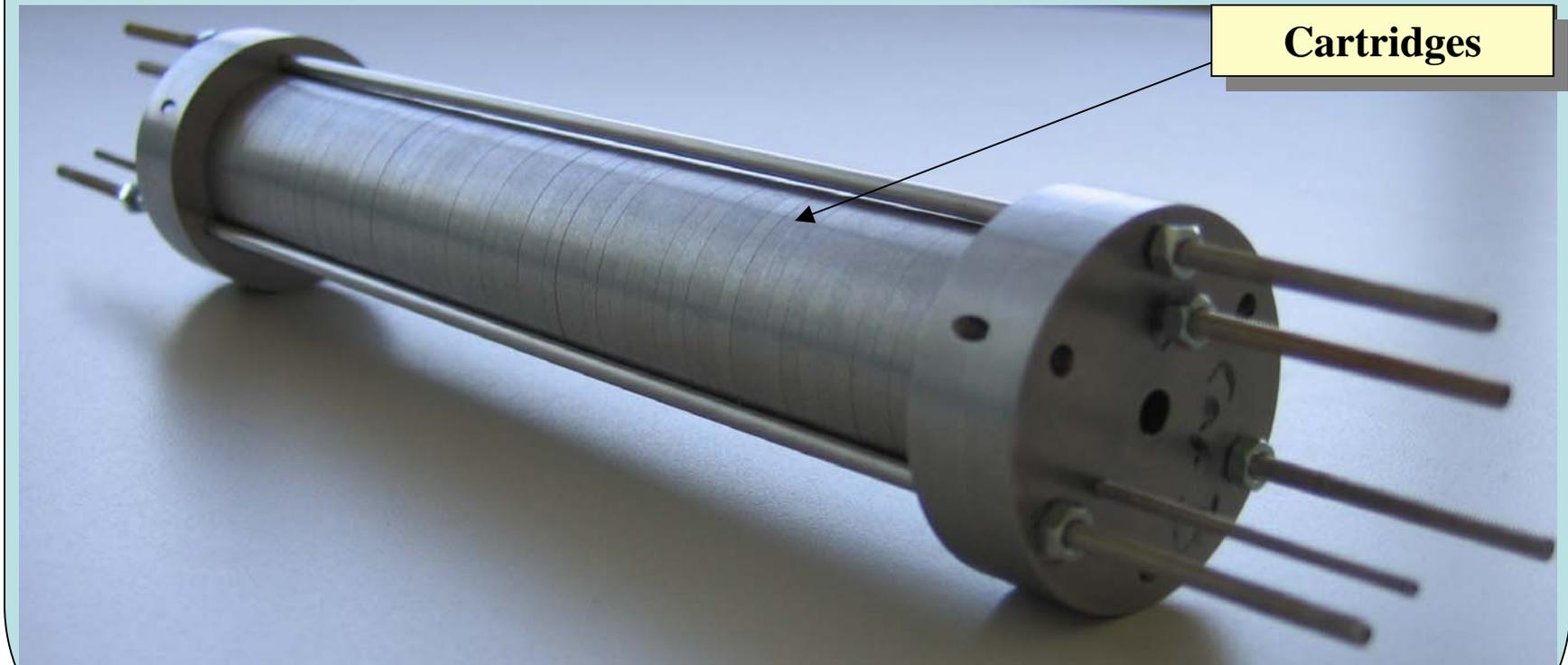


4. Parabolic indenters

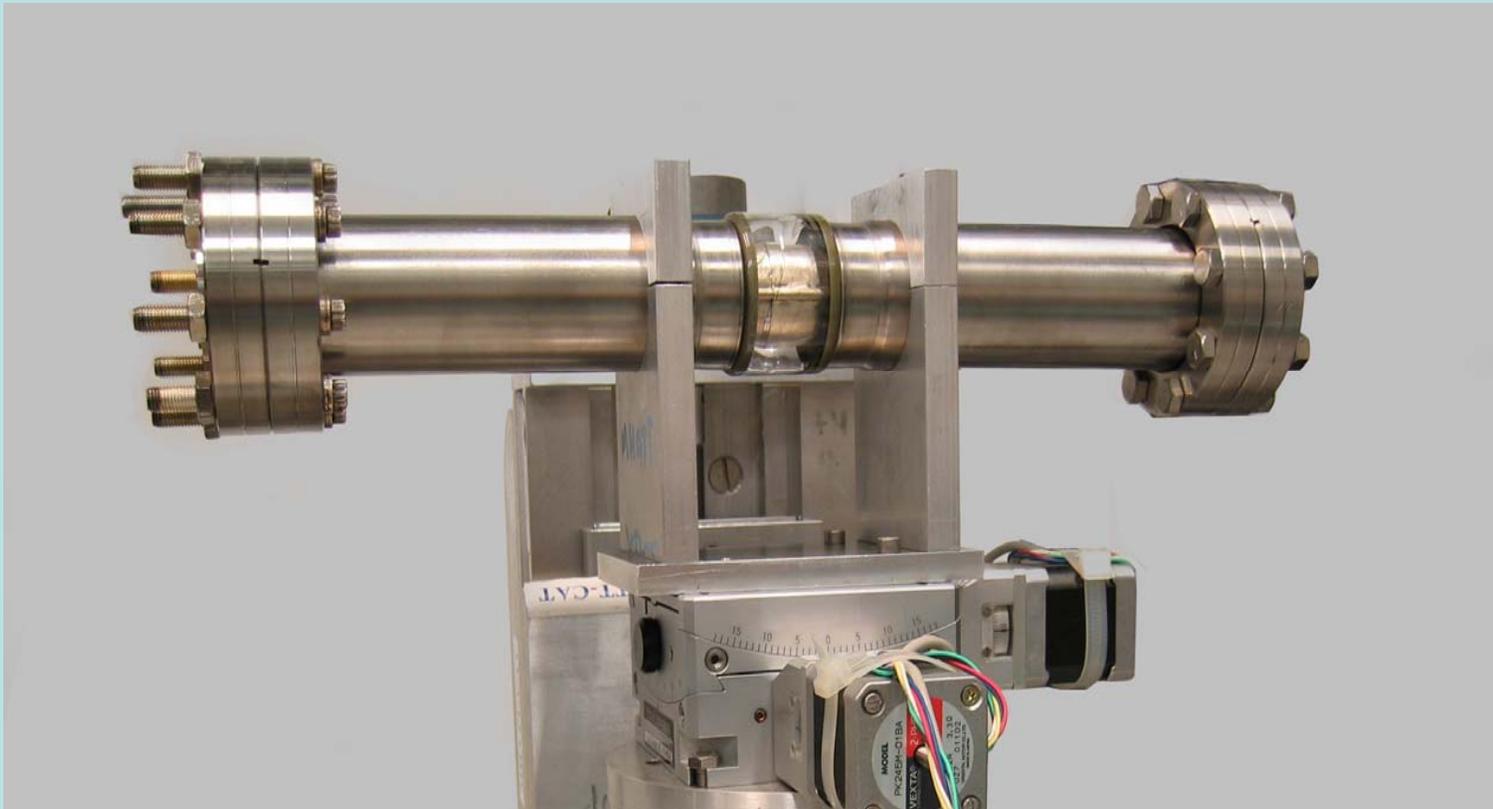


5. Manual press

Assembled Cartridges



Housing Assembly



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Fabrication Process

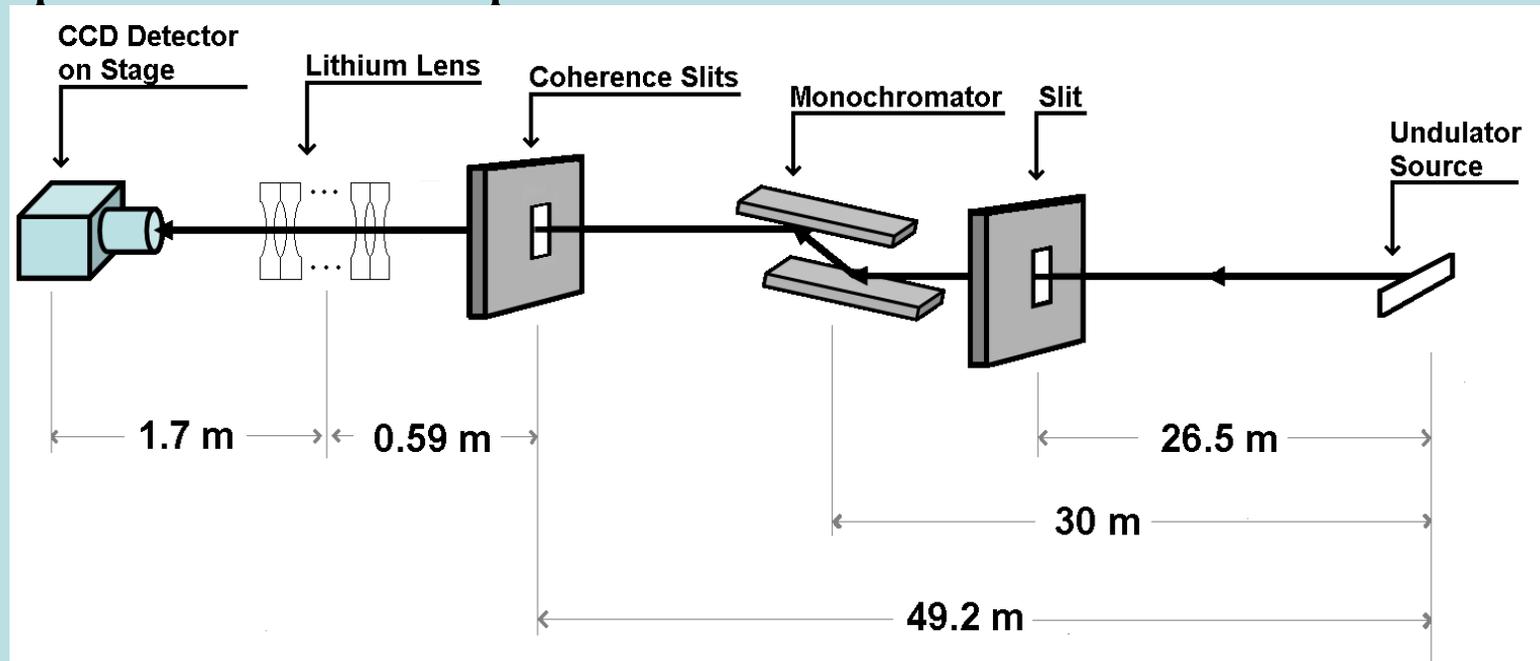
- Lenslet disks punched out from lithium foil
- Each lenslet disk placed and held in a cartridge unit
- Cartridge is placed in a manual press onto alignment pins
- Lenslet is pressed by a pair of parabolic indenters mounted in the precision press
- Cartridges aligned using alignment pins in an assembly
- Assembled lenslets are set securely in a housing unit having a Be window at each end
- All work is carried out in dry atmosphere

Prototype Li Lens Specifications

- To focus monochromatic (~ 10 keV) x-rays
- Beam size set by ~ 0.5 mm x 0.5 mm slit at 30 m
- Desired focal distance ~ 1 - 2 m
- CNC-machined stainless steel parabolic indenters
- Indenter tip radius is 100 μm ; aperture ~ 500 μm
- A set of 32 lenslets fabricated and assembled
- Expected focal length of 1.7 m at 10 keV

Testing & Evaluation

Experimental setup



Note: Slits do not affect the source size as viewed by the lens

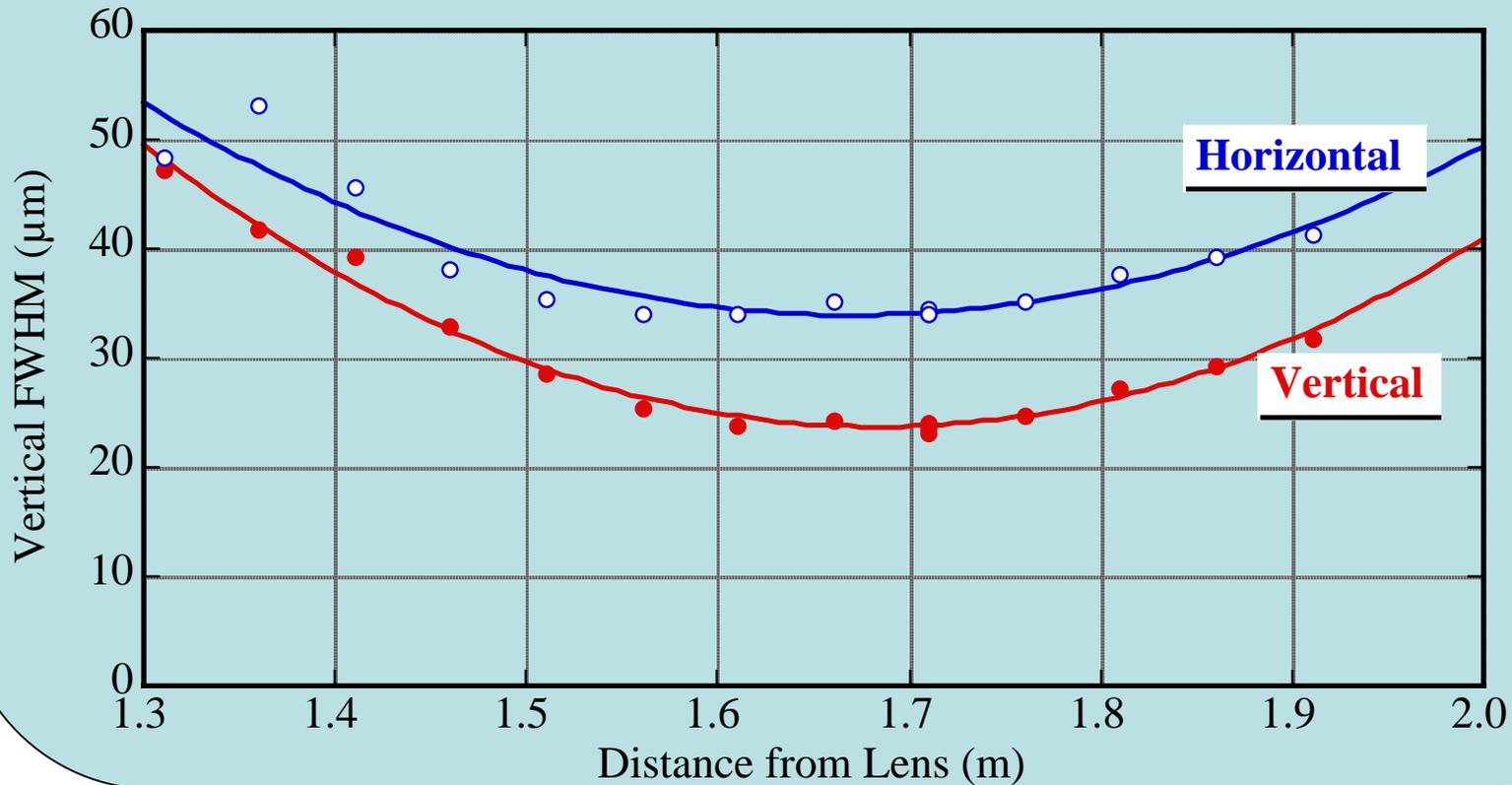
Testing & Evaluation, Cont...

- Experimental goal:
 - Measure location and size of focal spot
 - Measure lens transmission
 - Obtain gain
 - Compare with expectations
- Note:

$$\text{Demagnification} = 50/1.7 = 1/29$$

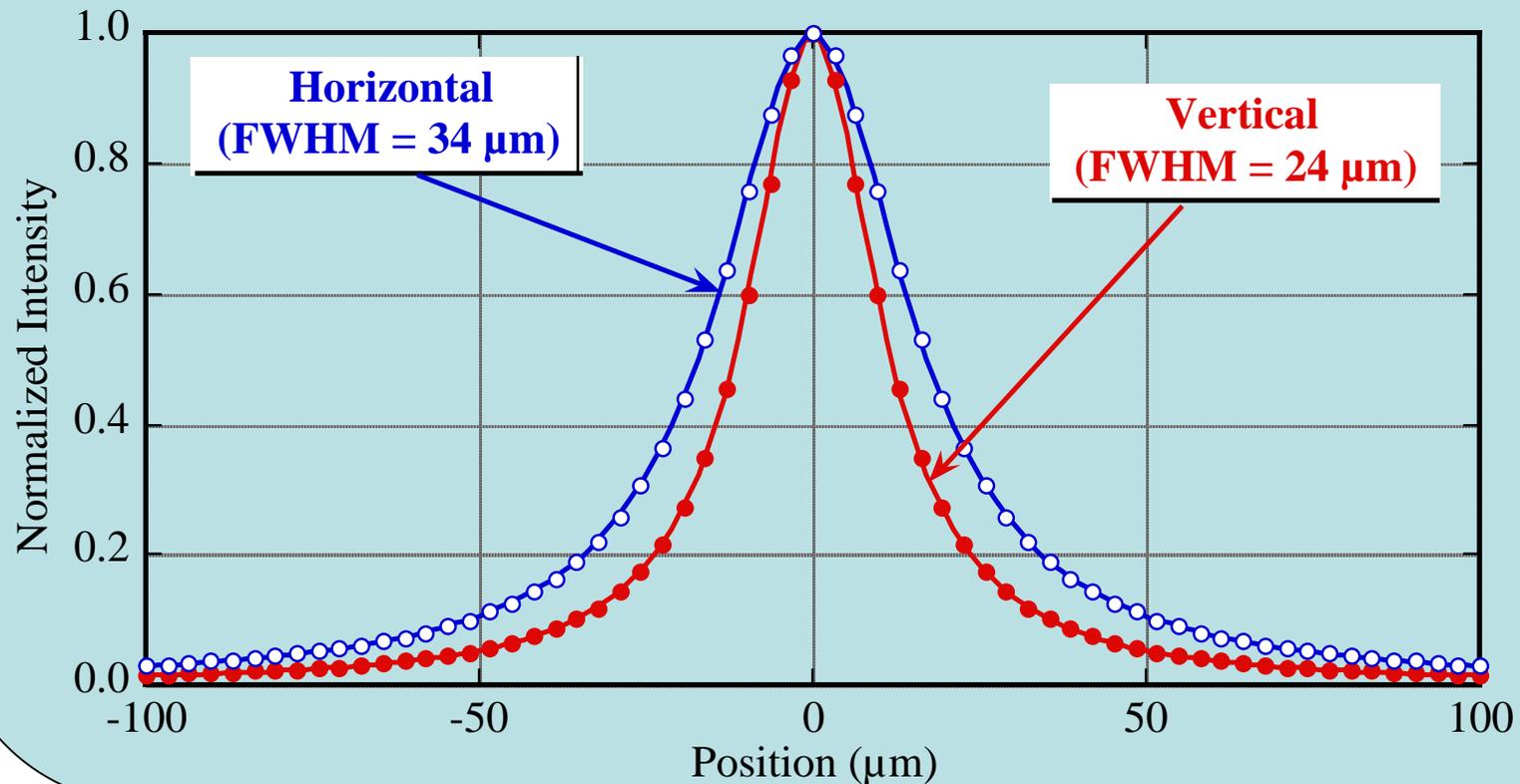
Testing & Evaluation, Cont...

Measuring image size along optical axis

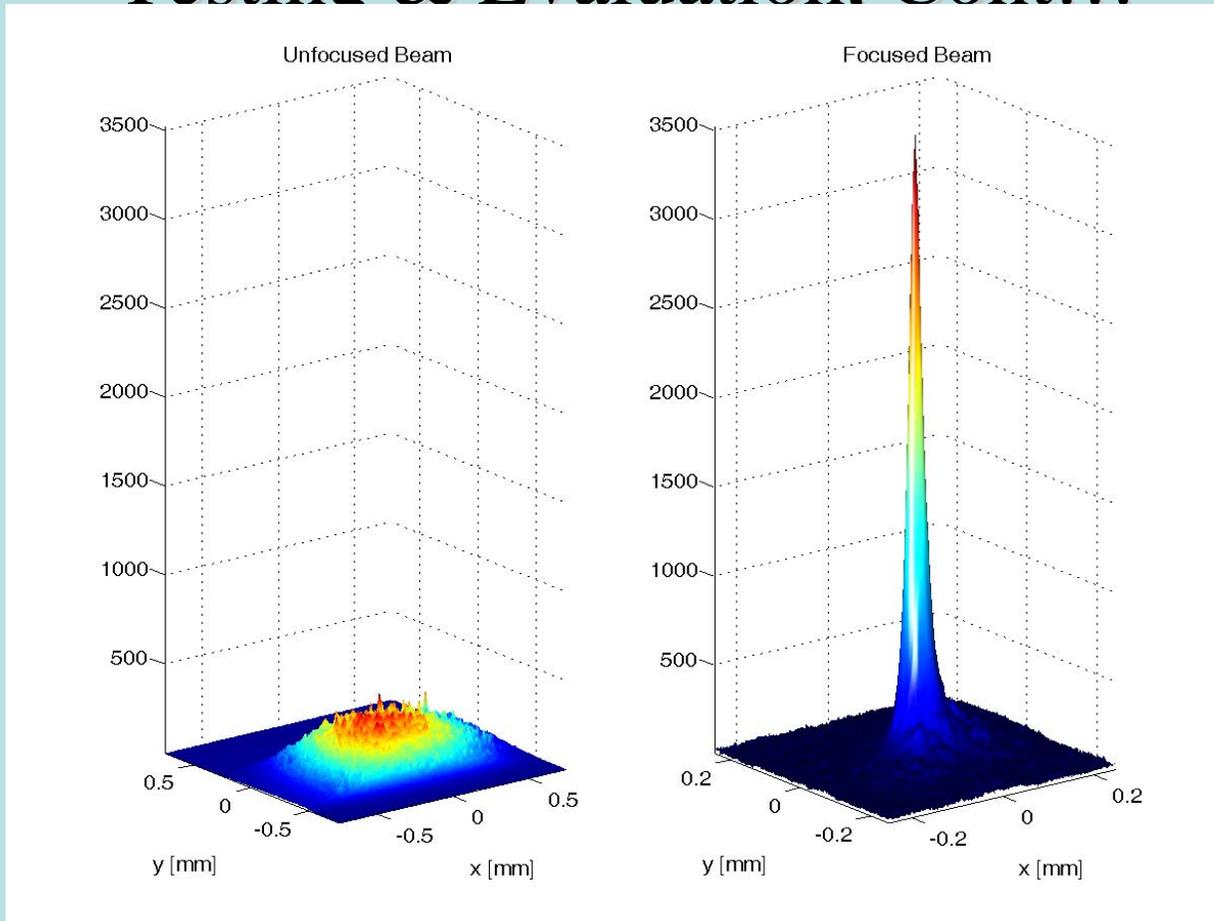


Testing & Evaluation, Cont...

Profile of the beam at the focal spot



Testing & Evaluation. Cont...



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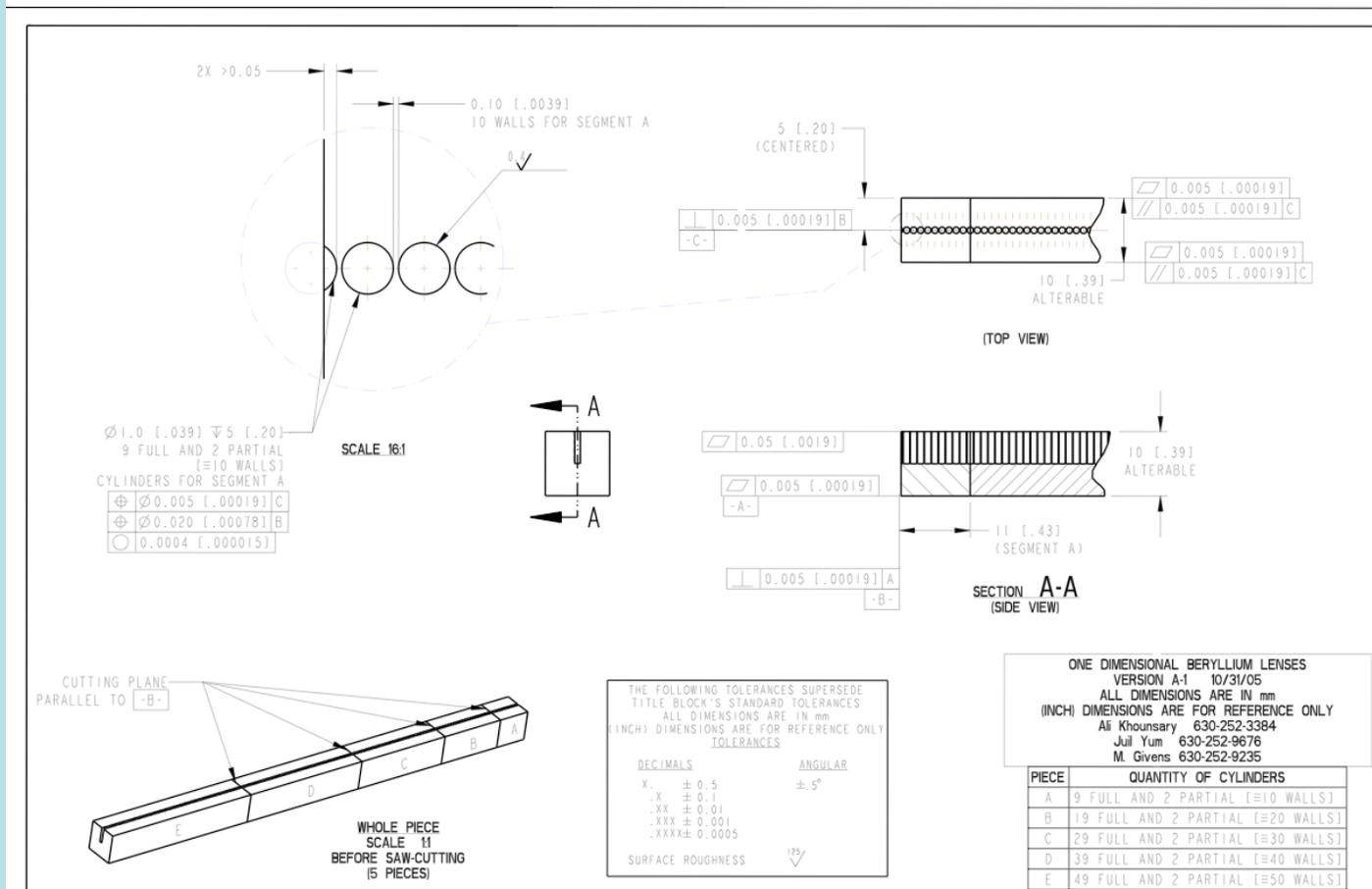
Lithium Lens Summary Results

- Transmission (average)
 - Measured: ~ 85%; Expected ~ 85%
- Focal Distance:
 - Measured: 1.71 m; Expected: 1.70 m
- Gain (increase in peak intensity):
 - Measured: ~ 18; Expected ~ 800
- Focal Size FWHM):
 - Horizontal: Measured: 34 μm ; Expected: (634/29) ~ 22 μm
 - Vertical: Measured: 24 μm ; Expected: (21/29) ~ 0.7 μm

Beryllium CRL

- $R = 0.5$ mm
- $N=10,20,30,40,50$, tested only $N=50$.
- High purity Be used
- Wall thickness ~ 100 μm
- Roughness < 0.1 μm rms
- Conventional CNC drilling
- No post drilling processes

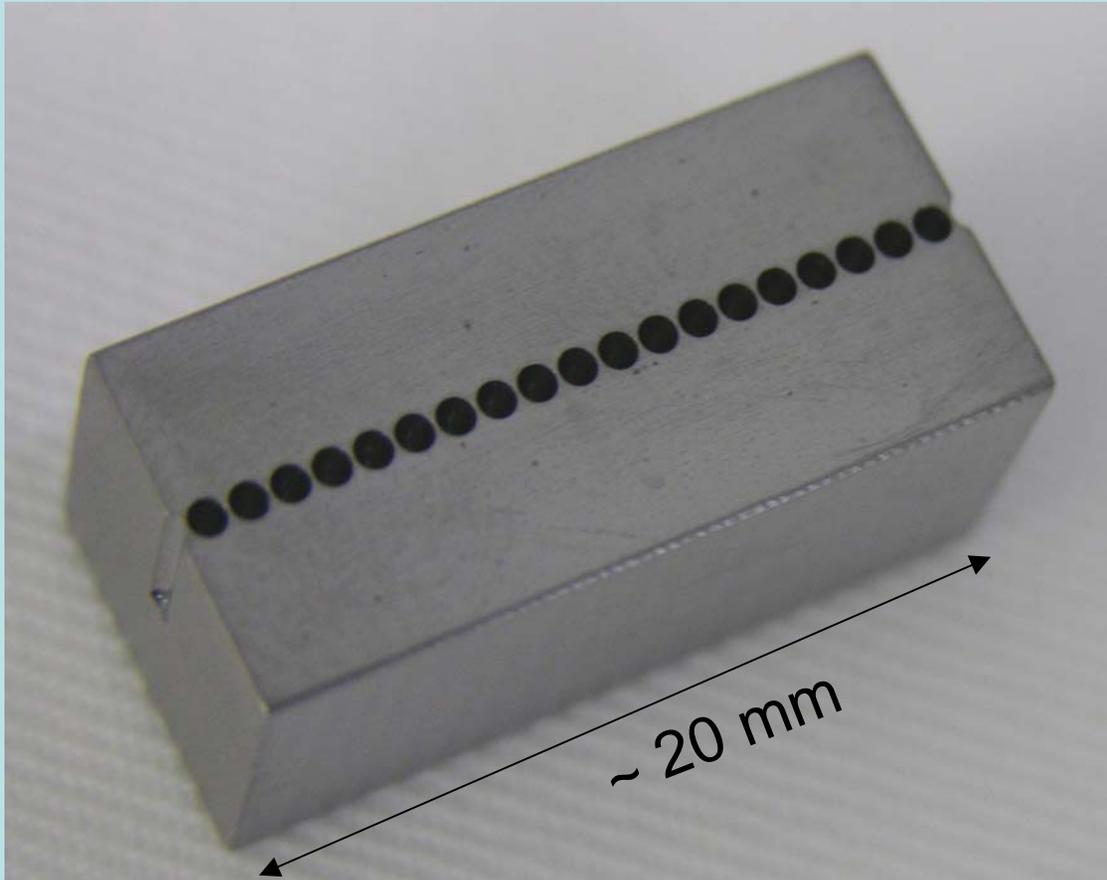
Lens Design



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Be Lens



Experimental Procedure

- White beam slit set to 0.5 mm x 0.5 mm @ 26.5 m
- Si (111) monochromatic beam @ 11 keV, detuned by 25%
- Variable opening slit immediately upstream of the lens
- Transmission measurement by scanning the lens across a narrow beam
- Beam size measured by a knife edge scanned vertically
- Best focus determined by moving the knife edge along optical axis
 - Lens 49.8 m from source
 - Vertical source size FWHM ~ 20 μm

Experimental Setup

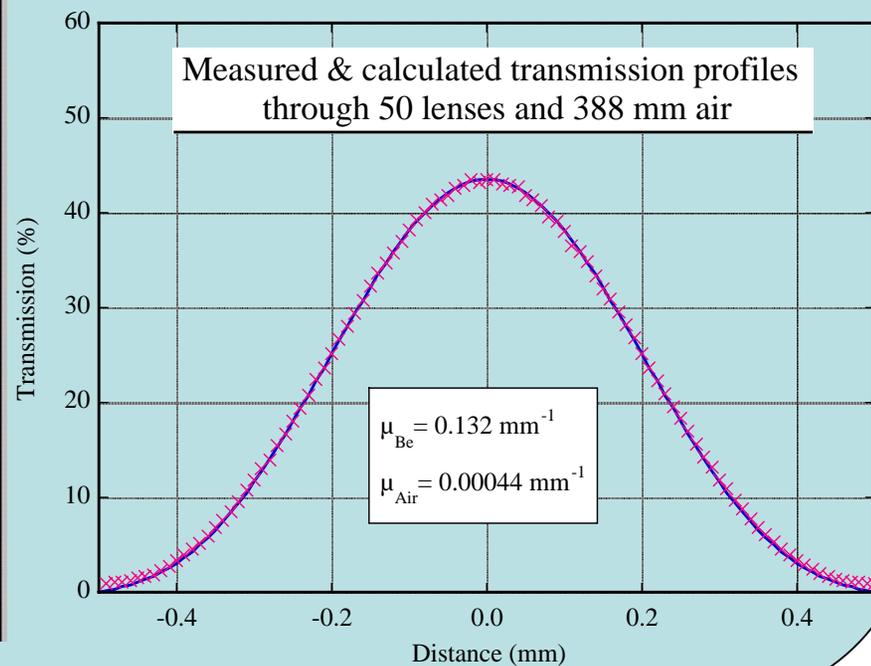
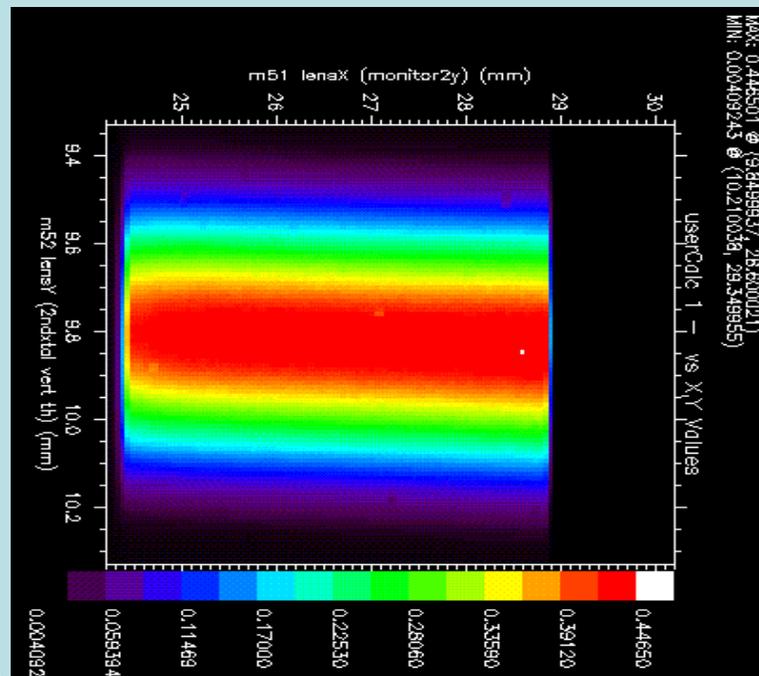


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Transmission through the Lens

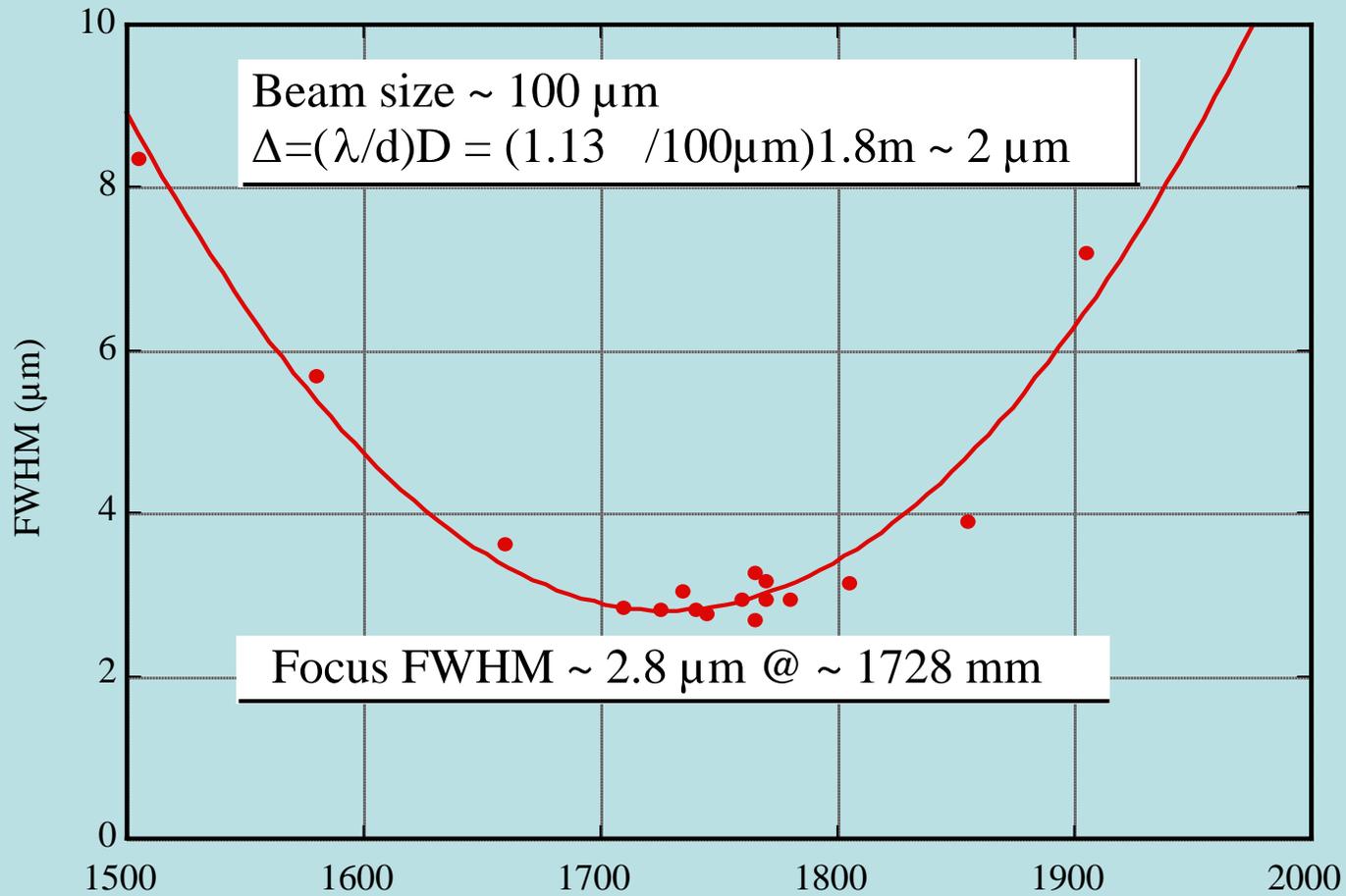
A 2D scan of the lens over a 30 μm (H) by 10 μm (V) beam.



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Focal distance measurements

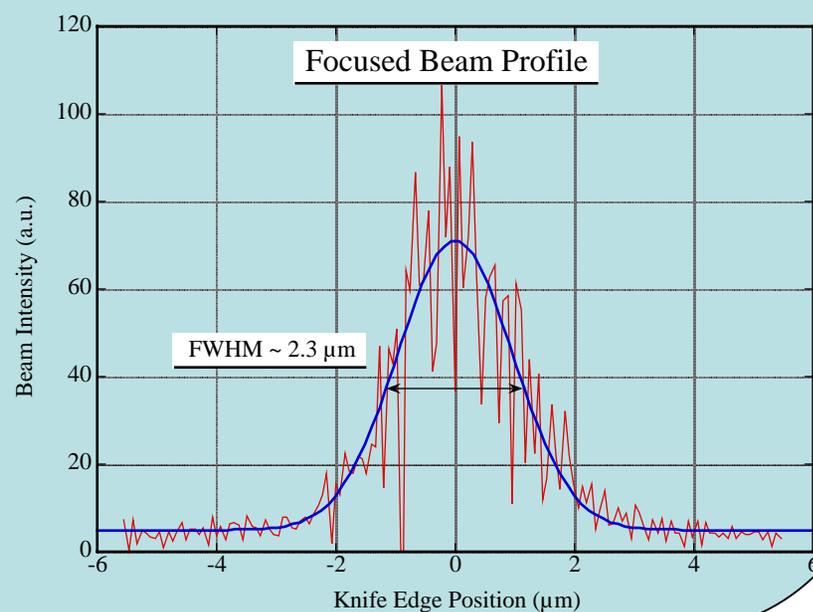
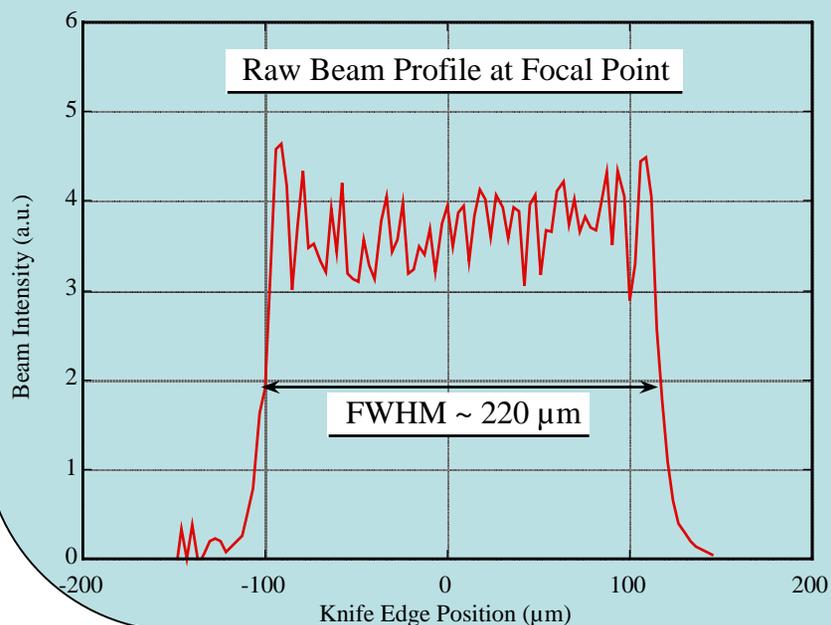


Typical Focused Beams Obtained

Gain $\sim 74/3.9 \sim 19$

Peak/tail $\sim 70/5 = 14$

FWHM $\sim 2.3 \mu\text{m}$ (diffraction limit $\sim 0.9 \mu\text{m}$)



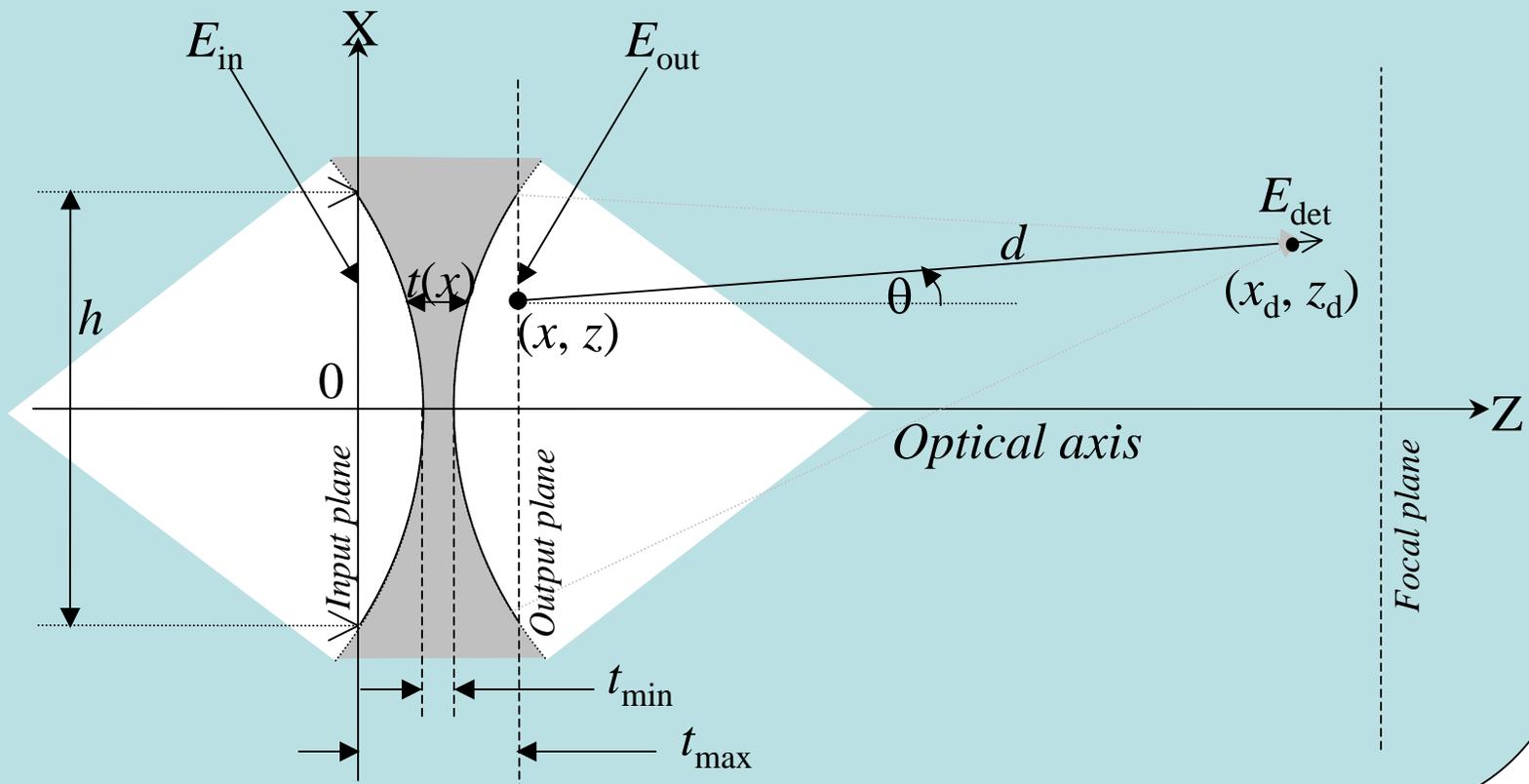
Cylindrical Be lens conclusions

- Peak transmission 43%, as expected with $\mu_{\text{Be}} = 0.132 \text{ mm}^{-1}$
- Focal distance: measured 1.73 m, expected 1.77 m
- Focal size: measured $\sim 2.3 \text{ }\mu\text{m}$, expected $20/D = 0.7 \text{ }\mu\text{m}$
- Blurring from GaAs knife edge & horizontal extent of beam
- Gain: Measured ~ 19 . Expected ~ 75

$$\frac{\text{Slit size}}{\text{Ideal focus size}} \text{Transmission} = \frac{220 \text{ }\mu\text{m}}{0.7 \text{ }\mu\text{m}} 0.24 \approx 75$$

- Accurate cylindrical lenses made; surface can be improved

1-D Lens Simulation



Lens thickness profiles

- Circular profile:

$$t_{\text{circular}}(x) = t_{\text{min}} + 2r \left(1 - \sqrt{1 - \frac{x^2}{r^2}} \right)$$

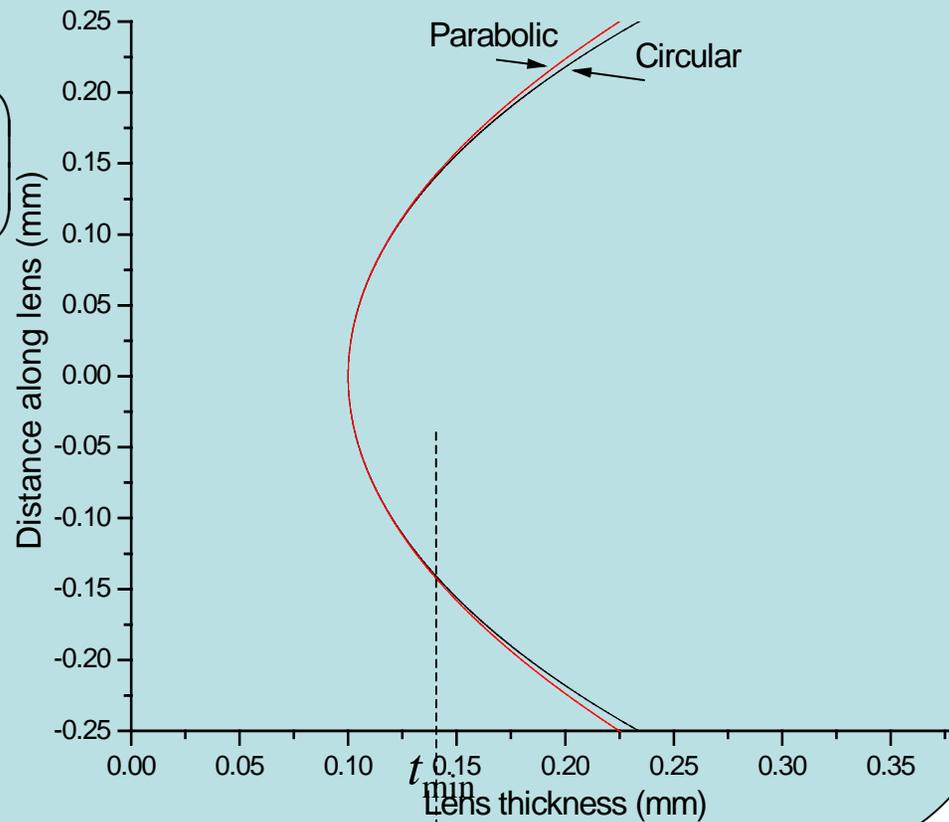
- Parabolic profile:

$$t_{\text{parabolic}}(x) = t_{\text{min}} + \frac{x^2}{r}$$

- Thickness parameters:

$$r = 0.5 \text{ mm}$$

$$t_{\text{min}} = 0.1 \text{ mm}$$



Wave-optics calculations

- Incident (collimated) plane wave: $E_{in} = E_0$
- Output (refracted) wavefield:

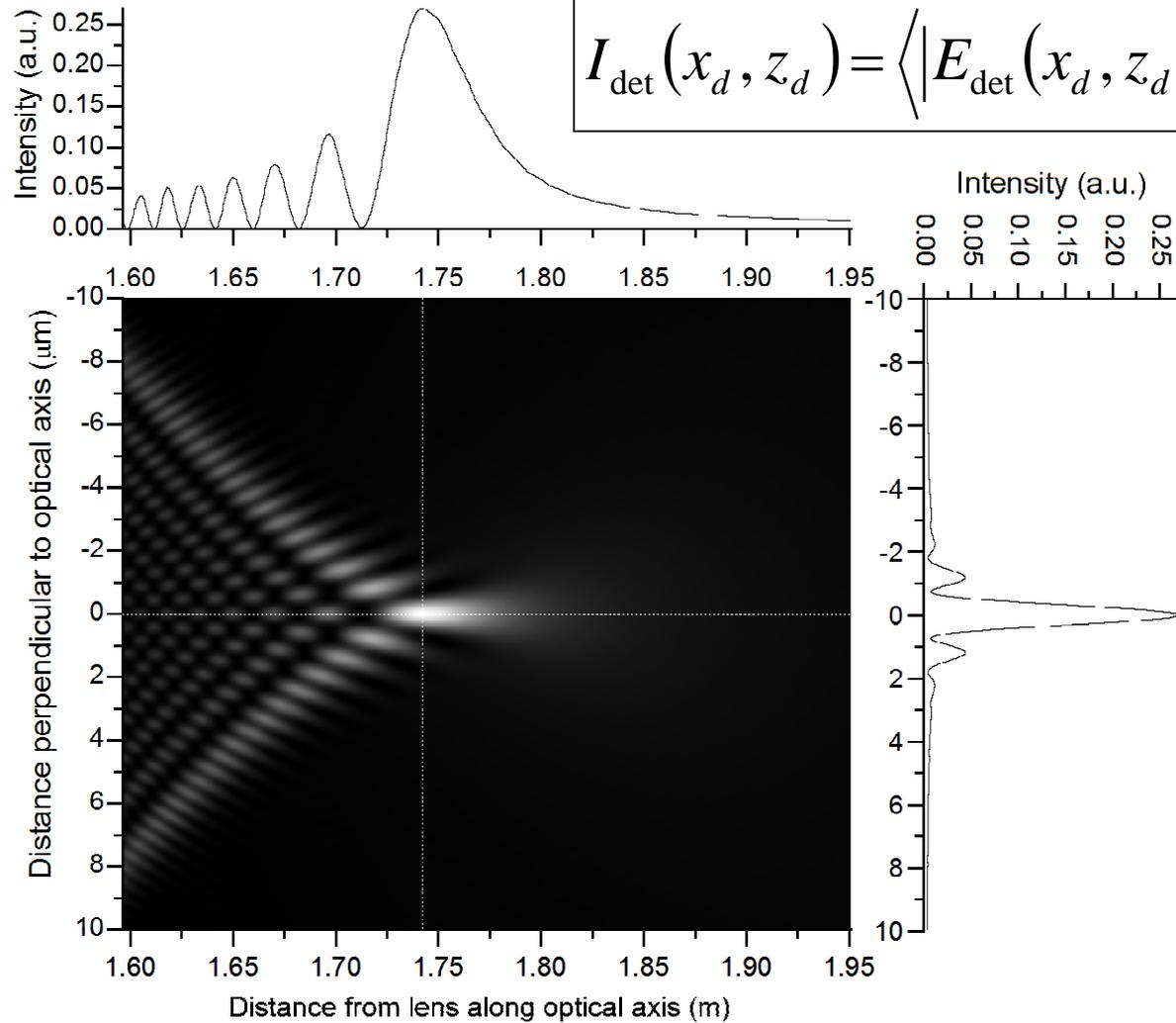
$$E_{out}(x, y) = E_0 e^{iknt(x, y) + ik[t_{max} - t(x, y)]} = E_0 e^{ik[t_{max} - \delta t(x, y)]} e^{-k\beta t(x, y)}$$

- Detected wavefield:

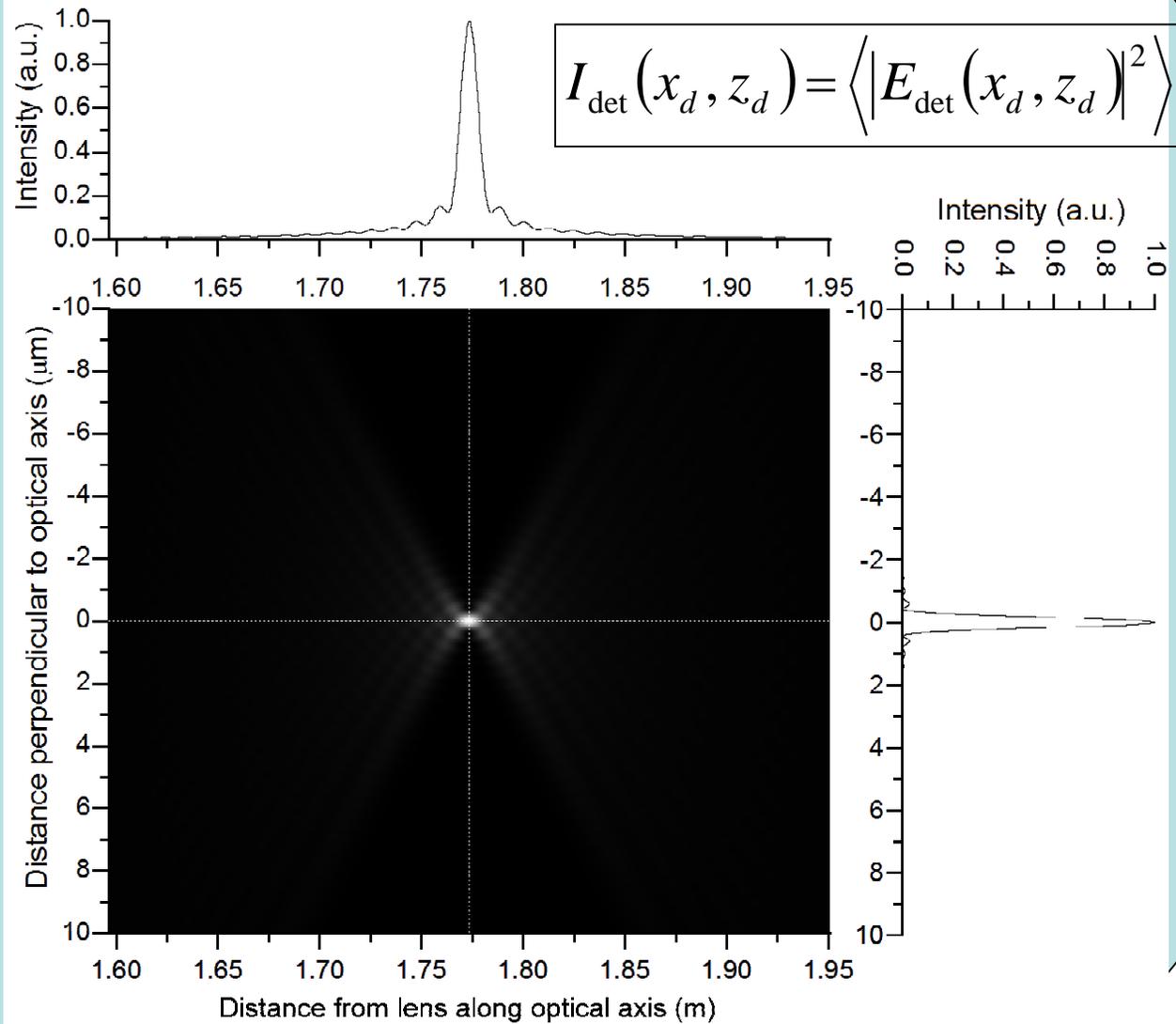
$$E_{det}(x_d, z_d) = \frac{-i}{2\lambda} \int_{-h/2}^{h/2} E_{out}(x, z) \frac{e^{-ikd}}{d} (1 - \cos \theta) dx$$

The detection point (x_d, z_d) is moved in the x - z plane to calculate the complex amplitude in 2D

Intensity map near the focal point of 50 circular profile lenses



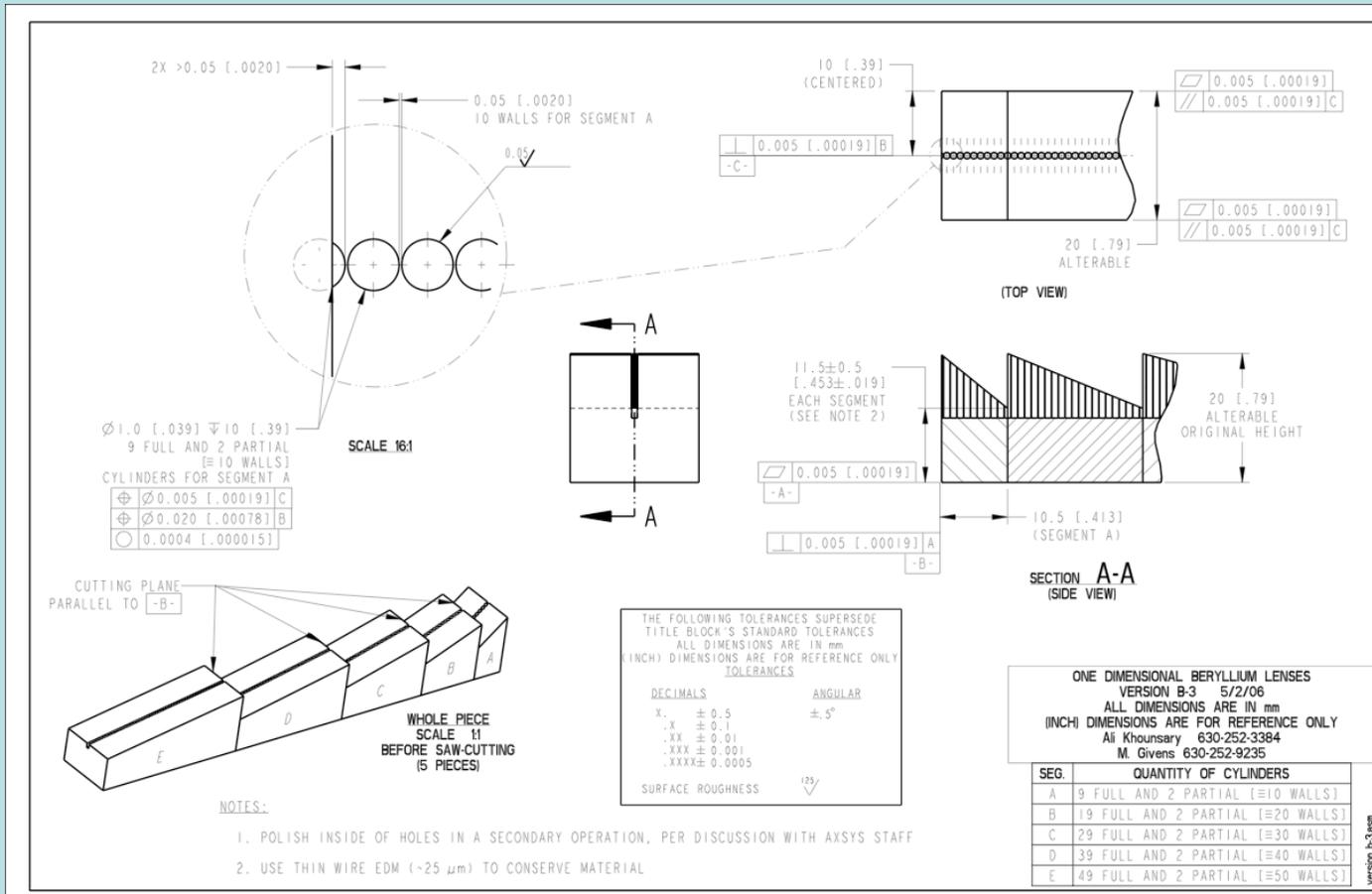
Intensity map near the focal point of 50 parabolic profile lenses



Future Plans

1. Better understanding of mechanical behavior of Li (spring back, flow, adhesion, etc.)
2. Improved indenter (surface profile / polish)
3. Fabricate indenters with smaller tip radii
4. Characterize figure/finish of indenters and indented Li (dry-room metrology or replication needed)
5. Improve precision & alignment in pressing Li process
6. Improve surface finish and wall thickness of Be lenses
7. Carry out wavefield calculations to simulate realistic lenses and features

Second Generation Be Lenses



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Summary

1. Fabrication of parabolic Li lens using a precision press demonstrated
2. First generation Li lens provides reasonable performance and an 18x gain
3. Lens imperfections contribute substantially to focus size broadening, blowing up the image by about 25 μm in both directions
4. First generation Be cylindrical lens 2.5 μm focal spot achieved
5. A gain of ~ 19 with Be lens and a focal size of $\sim 2 \mu\text{m}$ obtained
6. Plan to carry out improvements in Be and Li lenses, as well as simulation of their performance

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